



IFW  
2828/18

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **HAYASHI, Nobuhiko**

Group Art Unit: **2828**

Serial No.: **09/532,786**

Examiner: **Armando RODRIGUEZ**

Filed: **March 22, 2000**

P.T.O. Confirmation No.: 8588

For. **SEMICONDUCTOR LASER DEVICE AND METHOD OF FABRICATING THE SAME**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: December 13, 2004

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated September 2, 2004 for one month, from December 2, 2004 to January 2, 2005.

Attached please find a check in the amount of \$120.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS,  
HANSON & BROOKS, LLP

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120.00 OP

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PATENT TRADEMARK OFFICE